



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

October 10, 2024	
IGI Report Number	LG658496071
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	11.48 X 8.26 X 5.51 MM

## GRADING RESULTS

Carat Weight	5.10 CARATS
Color Grade	E
Clarity Grade	VS 1

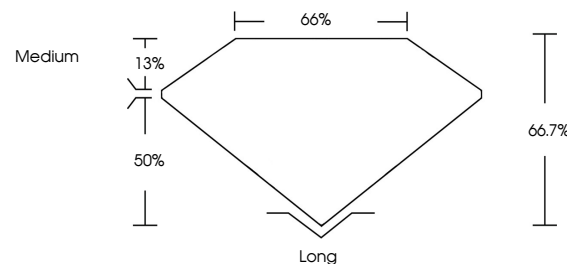
### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG658496071

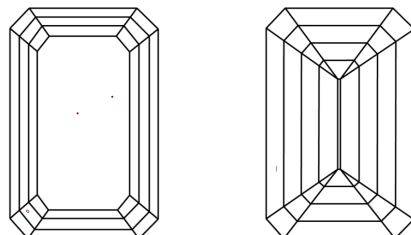
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG658496071  
Report verification at [lgi.org](https://lgi.org)

## PROPORTIONS



## CLARITY CHARACTERISTICS



### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

## COLOR

D E F G H I J Faint Very Light Light

## CLARITY

IF	VVS <sup>1,2</sup>	VS <sup>1,2</sup>	SI <sup>1,2</sup>	I <sup>1,3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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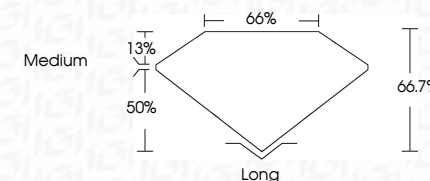
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 EMERALD CIT

	EMERALD CUT		11.48 X 5.25 X 5.51 MM		6.10 CARATS	
	Carat Weight		Color Grade		E	
	Clarity Grade		VS 1		66.7%	
	Depth		Table		66%	
	Girdle		Medium			
	Culet		Long		EXCELLENT	
	Polish		Symmetry		EXCELLENT	
	Fluorescence		None		NONE	
	GIA Report #		64182184		GIA # 64182184	

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